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In re application of :
Yuichiro MIYAMAE ET AL :
Serial No. 10/537,156 : Mail Stop: PCT BRANCH
Filed: May 31, 2005 :
Title: Plasma display and method of :
producing phosphor used therein :

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed herewith is a copy of the Official Filing Receipt for the above-identified application marked in red indicating corrections to be made thereto.

Accordingly, it is requested that the PTO issue a Corrected Filing Receipt reflecting these corrections.

Respectfully submitted,

YUICHIRO MIYAMAE ET AL

By

Jeffrey R. Filipek
Registration No. 41,471
Attorney for Applicants

/eak
WENDEROTH, LIND & PONACK, L.L.P.
2033 K. St., N.W., Suite 800
Washington, D.C. 20006-1021
Telephone (202) 721-8200
December 29, 2005



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 2033 K STREET N. W.
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CONFIRMATION NO. 1453

FILING RECEIPT



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Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Yuichiro Miyamae, Takatsuki-shi, JAPAN;
 Masaki Aoki, Mino-shi, JAPAN;
 Kazuhiko Sugimoto, Kyoto-shi, JAPAN;
 Keiji Horikawa, Kyoto-shi, JAPAN;
 Junichi Hibino, Kyoto-shi, JAPAN;
 Tanaka Yoshinori, Hirakata-shi, JAPAN;
 Setoguchi Hiroshi, Takasuki-shi, JAPAN;

Assignment For Published Patent Application

Matsushita Electric Industrial Co., Ltd., Kadoma-shi, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 513.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/14415 09/24/2004

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JAPAN 2003-335269 09/26/2003

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NEXT

Non-Publication Request: No

PAGE

Early Publication Request: No

Title



OF

Plasma display and method for producing phosphor used therein

Preliminary Class

362

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